

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shuichi Kikuchi et al.

Art Unit : 2822

Serial No.: 09/943,667

Examiner: Toniae M. Thomas

Filed

: August 31, 2001

Title

: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE

**SAME** 

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## AMENDMENT IN REPLY TO ACTION OF OCTOBER 15, 2003

Please amend the above-identified application as follows:

RECEIVED

JAN 20 2004

TC 2800 MAIL ROOM

## CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

JANUARY 9, 2004

Date of Deposit

Signature

PATRICIA F. SUCHANEIC

Typed or Printed Name of Person Signing Certificate